

<b>Notice of References Cited</b>	Application/Control No. 09/966,121		Applicant(s)/Patent Under Reexamination WALACAVAGE ET AL.	
	Examiner Kibrom K. Gebresilassie		Art Unit 2128	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,998,206 A	03-1991	Jones et al.	700/96
*	B	US-5,574,637 A	11-1996	Obata et al.	700/2
*	C	US-5,796,618 A	08-1998	Maeda et al.	700/182
*	D	US-6,223,134 B1	04-2001	Rust et al.	702/121
*	E	US-6,263,487 B1	07-2001	Stripf et al.	717/171
*	F	US-6,442,441 B1	08-2002	Walacavage et al.	700/86
*	G	US-6,470,301 B1	10-2002	Barral, David	703/1
*	H	US-6,526,373 B1	02-2003	Barral, David	703/6
*	I	US-6,847,922 B1	01-2005	Wampler, II, Charles W.	703/1
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Kanai, T. Kishinami, A virtual Verification Environment for the Sequence Control System Using VRML and JAVA, 1999 by ASME, pgs. 1-8.
	V	ThermaView Advanced Welder Diagnostics System, 1998.
	W	S. Vedapudi, "Using MCM to do Emulation of a Car Assembly Line" Brooks Automation Symposium '01, pgs 1-4.
	X	W. Dong, F. Palmquist, and S. Lidholm, "A Simple and Effective Emulation Tool Interface Development for Tricept Application" Proceedings of the 33rd ISR October 7-11, 2002, 4 pages.□□

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.